

Application No.	Applicant(s)	
10/655,941	LEBNER, MICHAEL	_
Examiner	Art Unit	
Kim M. Lewis	3743	

SEARCHED					
Class	Subclass	Date	Examiner		
606	213-218	5/14/2004	KML		
602	41-59	5/14/2004	KML		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
				
	T-1/2-2016			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
conducted and inventor name search: see the enclosed sheet.	5/13/2004	KML		
consulted with Parent application 09450488, now U.S. Patent No. 6,329,564	5/13/2004	KML		
conducted an East BRS seach	5/14/2004	KML		
consulted 10/014832 office actions (application file wrapper could not be located)	5/14/2004	KML		